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IN THE UNCLEASE TATES PATENT AND TRADEMARK OFFICE

In re the Application of: OZAKI, Takashi, et al.

Group Art Unit: 2812

Serial No.: 10/517,765

Examiner: Not Yet Assigned

Filed: December 23, 2004

P.T.O. Confirmation No.: 6791

For.

SUBSTRATE TREATING APPARATUS AND METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE

PETITION FOR EXTENSION OF TIME

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Date: February 3, 2006

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated July 5, 2005 for five months, from September 5, 2005 to February 5, 2006.

Attached please find a check in the amount of \$2,160.00 to cover the cost of the extension for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340.

Respectfully submitted,

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